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#12/Electon  
1/21/03  
vsIN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Jiping Li, Peter G. Borden

Assignee: Boxer Cross Inc

Title: Evaluating Sidewall Coverage In A Semiconductor Wafer

Serial No.: 09/788,273

Filing Date: 2/16/2001

Examiner: Michelle Estrada

Group Art Unit: 2823

Docket No.: BOX009 US

COMMISSIONER FOR PATENTS  
Washington, D. C. 20231San Jose, California  
December 30, 2002RECEIVED  
JAN - 6 2003  
TECHNOLOGY CENTER 2800**RESPONSE TO OFFICE ACTION**

Dear Sir:

In response to the Office Action dated December 3, 2002 Applicants elect for further prosecution the first specie related to "a method comprising illuminating the wafer with a beam of electromagnetic radiation having a majority of energy polarized in a direction other than parallel to a longitudinal direction of the feature." Claims 1-11, 13-17, and 23-37 are believed to read on this first specie.

Attached is a copy of a power of attorney authorizing the undersigned to prosecute the above-identified application. Although it was filed on October 28, 2002, the above-identified Office Action was still addressed to the old address. Please address all future correspondence to: Silicon Valley Patent Group LLP, 2350 Mission College Blvd, Suite 360, Santa Clara, CA 95054 which is the address associated with our customer number 34036. If there are any questions, please call the undersigned at 408-982-8200, ext 3.

Via Express Mail Label No.

EU 789 864 432 US

Respectfully submitted,

Omkar K. Suryadevara  
Attorney for Applicant(s)  
Reg. No. 36,320